Critical adsorption at chemically structured substrates

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We consider binary liquid mixtures near their critical consolute points and exposed to geometrically at but chemically structured substrates. The chemical contrast between the various substrate structures amounts to opposite local preferences for the two species of the binary liquid mixtures. Order parameters proles are calculated for a chemical step, for a single chemical stripe, and for a periodic stripe pattern. The order parameter distributions exhibit frustration across the chemical steps which heals upon approaching the bulk. The corresponding spatial variation of the order parameter and its dependence on temperature are governed by universal scaling functions which we calculate within meaneld theory. These scaling functions also determine the universal behavior of the excess adsorption relative to suitably chosen reference systems.

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I. INTRODUCTION

Chem ically structured substrates have gained signicant importance within the last years. Since it is possible to produce networks of chem ical lanes at the m-scale and even below these chem ically structured substrates have applications in micro-reactors, for the \lab on a chip", and in chemical sensors [1, 2]. They can operate with small amounts of reactants which is important when investigating expensive substances and substances which are available only in small amounts like biological material or when dealing with toxic or explosive materials. At these small scales the interaction of the uids with the substrate becomes important and there is the challenge to control the distribution and the ow of the uids on these structures.

In the following we investigate three di erent types of chem ically structured substrates, as shown in Fig.1. First we analyze—uid structures at a chem ical step (see Fig. 1(a)) which is in portant for understanding the local properties of—uids at the border of stripes. Next we consider a single chem ical stripe (see Fig.1(b)) as the simplest chem ical surface pattern, and—nally we study a periodic stripe pattern (see Fig. 1(c)) as the paradigmatic case for the investigation of adsorption at heterogeneous surfaces.

The chemical contrast on the substrates acts on the adjacent liquid [3, 4]. In order to impress the chemical pattern of the substrate on a one-component liquid, the chemical structure has to be chosen as a pattern of lyophobic and lyophilic regions. For binary liquid mixtures one chooses a pattern of two dierent substrate types, such that one component is preferred by one substrate type and the second component by the other substrate type. This lateral structuring of the substrate causes a rich uid-substrate interface structure which typically depends on the molecular details of the local force elds. However, in this study we focus on the particular case of the uid being close to a second-order phase

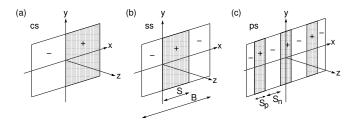


FIG. 1: The di erent chem ical substrate structures studied in this article: (a) chem ical step (cs), (b) single stripe (ss), (c) periodic stripes (ps). All systems are translationally invariant in the y-direction. The shading indicates di erent local preferences for, e.g., the two components of a binary liquid mixture exposed to the geometrically at surface of macroscopicly large lateral extension B.

transition. This is either the liquid-vapor critical point of a one-component liquid or the critical demixing transition of a binary liquid m ixture. In these cases the ensuing critical phenom ena are to a large extent universal in character, i.e., they render molecular details irrelevant in favor of universal scaling functions by involving spatial variations on the scale of the diverging correlation length. Near the critical point the surface patterning acts like a laterally varying surface eld of alternating sign. This generates an order param eter pro le characterizing critical adsorption of opposite sign such that the system is frustrated across the chemical steps. Upon approaching the bulk of the uid this frustration is healed and the healing is expected to be governed by universal scaling functions. In addition, the substrate patterning results in a change of the excess amount of adsorbed uid with respect to the case of critical adsorption on a homogeneous substrate. The excess adsorption is expected to be governed by universal scaling functions, too.

It is the purpose of this contribution to describe this scaling in terms of general renormalization group arguments and to calculate the corresponding universal scal-

ing functions to lowest order, i.e., within mean eld theory. If, as it is actually the case, the size of the lateral structures is comparable with the range of the correlation length, which can reach up to 100 nm close to the critical point, one can expect a rich interplay between the externally in printed patterns and the critical phenomena characterized by the correlation length.

1. Critical phenomena

In order to describe critical phenom ena [5, 6] one distinguishes properties to classify them . Starting with uncon ned systems one introduces the so-called bulk universality classes which are characterized by critical exponents and am plitudes which describe the dependence of various quantities, e.g., the order param eter and the correlation length, on the reduced temperature $t = \frac{T}{T}$ upon approaching the critical temperature Tc. These critical exponents are universal, i.e., the same for all m em bers of a universality class. The amplitudes usually are non-universal, whereas the number of independent non-universal amplitudes is limited; any non-universal am plitude can be expressed in terms of these independent non-universal amplitudes and universal amplitude ratios. O ne-com ponent uids near their liquid-vapor critical point and binary liquids near their dem ixing critical point belong to the Ising universality class like uniaxial ferrom agnets. These systems have two independent non-universal am plitudes. In this sense our subsequent analysis holds for all systems encompassed by the Ising universality class.

The order parameter indicates the degree of order in the system and has to vanish above the critical temperature in the absence of an ordering eld while below the critical temperature it takes a nite value. It is described by the universal critical exponent and a non-universal amplitude a: (t) = atj. For a one-component uid is the dierence between the density and its value at the critical point. In the case of a binary liquid mixture it is chosen as the dierence between the concentration of one uid component and its concentration at the critical demixing point.

The correlation length is de ned by the exponential decay of the bulk two-point correlation function G (r) for large distances (r ! 1) at temperatures o criticality (T \oplus T_c) and it is denoted as $^+$ above and as $^+$ below the critical temperature, respectively. It diverges according to the power law = $_0$):j with the universal critical exponent and the non-universal amplitudes $_0$. Their ratio $_0^+=_0^-$ is, however, universal. If the critical medium is brought near a substrate, surface universality classes come into play which we shall discuss in Sec.II.

2. Experim ental m ethods

Di erent techniques to produce chemical structures in the range of m and nm have been established [7]. In order to obtain topologically at but chem ically structured substrates one can take advantage of the self-ordering mechanism of self-assembled monolayers (SAM) in using block-copolym ersorm ixtures of polym ers which form structures while dem ixing [3, 8, 9]. The morphology and dom ain size of these structures depend on di erent characteristics of the materials and of the formation process. A nother possibility to produce structured substrates is to change the functionality of the SAM spartially by irradiating a hom ogeneous SAM which is covered with a mask that carries the desired structure [10]. A third method is the so-called micro-contact printing [11] where sam ples, e.g., produced with lithography, are used as a mold for an elastom er stam p. The structure of the original is copied by stamping a \thiolink" on gold covered substrates which chem isorbs there and forms a SAM. The em pty spaces between the patterns of the stam ped structure can be lled with a second thiol with a dierent functional end-group such that a topologically at but chem ically structured substrate is built up. As a last method we mention the exposure of oxidated titanium surfaces to UV-light [12, 13, 14].

In order to investigate the structural properties of uid system s near surfaces various experim entalm ethods have been developed: Ellipsom etry and especially phase modulated ellipsometry have been established in Refs. [15] and [16] m ore than 20 years ago and are still powerful tools [17, 18]. An incident light beam is re ected by the surface of interest and the ratio of the complex re ection am plitudes for polarizations parallel and perpendicular to the plane of incidence (\coe cient of ellipsom etry" or \ellipticity") is m easured. The order param eter is m odeled and related to the ellipticity via the spatially varying dielectric constant and can then be compared with the m easured value. In neutron or X-ray re ectom etry one m easures the re ectivity as a function of the momentum transfer normal to the surface of the sample. This reectivity spectrum is related to the refractive index pro le which itself is associated with the pro le of the order param eter [18, 19, 20, 21, 22]. A m ore direct m easurem ent of the adsorption of a component to a substrate can be carried out with a di erential refractom eter [23, 24]. Here a laser beam passes a measurement cell consisting of two compartments lled with the uid of interest and a reference liquid, respectively. The intensity of the de ected beam is proportional to their di erence in refractive index. By comparing this measured intensity with the one of a beam de ected by a measurement cell led with a liquid with known interfacial properties and the reference liquid one is able to infer the properties of the uid of interest.

W ith these methods critical adsorption on homogeneous substrates has been experimentally investigated (see Refs. [25] and [26] and references therein). On chem-

ically structured substrates mostly wetting experiments have been performed [27, 28, 29]. The present paper extends theoretical work on critical adsorption on chem – ically hom ogeneous [30, 31, 32, 33] and topologically [34] structured surfaces and work on wetting phenomena at chemically structured substrates [35, 36, 37, 38, 39] to the case of critical adsorption on geometrically at, but chemically structured surfaces.

The remainder of this paper is organized as follows: In Sec.II we introduce our model and in order to set the stage we recall previous results on critical adsorption at hom ogeneous substrates. In Sec.III we present our results for the critical adsorption at chemically structured substrates. We sum marize our indings in Sec.IV.

II. CRITICAL ADSORPTION AT HOMOGENEOUS SUBSTRATES

Boundaries, which come into play when investigating con ned systems, induce deviations from the bulk behavior. Near a critical point the Ising bulk universality class splits into three possible surface universality classes (denoted as normal, special, and ordinary surface universality class, respectively) characterized by surface critical exponents and amplitudes [30, 31]. The boundary conditions applied to the system determine the surface universality class the system belongs to. The behavior of the bulk is not a ected by the boundaries.

It has turned out that in the sense of renormalization group theory it is sulcient to describe the presence of the substrate by a surface eld h and the so-called surface enhancement c [31]. (These names originate from the corresponding description of surface magnetic phenomena [30, 31], see also, c.f., Eq. (7).) The surface enhancement is related to the couplings between the ordering degrees of freedom at the surface.

The so-called ordinary surface universality class is characterized by a vanishing surface eld and a positive surface enhancement ($h_1 = 0$; c > 0) which suppresses the order parameter at the surface below its bulk value. For magnetic systems this elect of missing bonds is the generic case.

The special surface universality class, describing a multicritical point, requires in addition to a vanishing surface eld a surface enhancement which within mean eld theory vanishes ($h_1=0$; c=0) and causes a at order parameter prole in the vicinity of the substrate; uctuations induce a divergence of the order parameter prole at the surface.

The norm al surface universality class is characterized by a non-vanishing surface eld and the absence of the surface enhancement $(j_1,j>0;c=0)$ which leads to an order parameter value at the surface larger than in the bulk, even above the critical temperature where the bulk value of the order parameter is 0. For uid systems the norm al surface universality class is the generic case. In contrast, in the context of magnetism an order parameter

which is larger at the surface than its value in the bulk can be obtained in the absence of surface elds but for a negative surface enhancement ($h_1=0;c<0$). Since this is rather uncommon for magnetic systems, the normal surface universality class is also referred to as the so-called extraordinary surface universality class. The fact that the normal and the extraordinary cases are equivalent and identical at their exed points, (h_1 j! 1; c=0) for uid systems and ($h_1=0;c$! 1) for magnetic systems, and thus identical with respect to their asymptotic behavior, was predicted by Bray and Moore [40] and later proven by Burkhardt and Diehl [41]. In the following we shall focus on the normal and extraordinary surface universality classes, respectively.

A hom ogeneous substrate con ning a binary liquid mixture inevitably has a preference for one of the two components. This preference becomes pronounced at the critical point and leads to an enrichment of the preferred component at the substrate. At the critical temperature the local order parameter prole decays algebraically towards its bulk value. This phenomenon has been called critical adsorption [32].

In the case of planar hom ogeneous substrates besides the correlation length — the distance z from the substrate is the other relevant length scale. If this length is scaled with the bulk correlation length —, the order parameter pro le (z;t) takes the following scaling form at the xed points (h;j! 1;c=0) and $(h_1=0;c! 1)$, respectively:

$$(z;t) = a \pm j P$$
 $w = \frac{z}{}$ fort? 0; (1)

with the scaling variable w=z= which describes the distance from the substrate in units of the correlation length .

The scaling functions P (w) are universal after xing the non-universal amplitude a and the non-universal amplitude $_0^+$ of the correlation length . (Recall that the ratio $_0^+=_0^-$ is universal and therefore the amplitude $_0^-$ is xed along with the amplitude $_0^+$.) The amplitude a is chosen in such a way that the scaling function P (w) below the critical temperature tends to 1 for large distances from the substrate, i.e., the amplitude a corresponds to the amplitude of the bulk order parameter (z! 1;t<0) = a tj. W ith this choice one nds the following behavior of the scaling functions:

$$P (w ! 0) w -;$$
 (2)

$$P^{+}$$
 (w ! 1) e^{w} ; (3)

$$P (w ! 1) 1 e^{w} : (4)$$

Away from the renormalization group xed point the surface eld h and the surface enhancement chave - nite values. They appear as additional parameters in the scaling functions with powers of the reduced temperature as prefactor due to scaling with the correlation length:

$$(z;t) = a \pm j P \quad (\pm j (_0))^{-1} z; \pm j \quad (_0)^{\frac{d}{2}} h_1; \pm j \quad _0 \Leftrightarrow (a,b)$$

where $_{1}$ and are surface critical exponents [31] and d denotes the spatial dimension of the system .

The explicit calculation of the order parameter proles (z;t) starts from the following xed point H am iltonian H [] = H_b [] + H_s [] which separates into the bulk part H_b [] in the volume V and the surface part H_s [] on the surface S [30, 31]:

$$H_{b}[] = \begin{cases} Z \\ d^{d-1}r_{k} dz & \frac{1}{2}(r)^{2} + \frac{1}{2} & ^{2} + \frac{u}{4!} & ^{4} \end{cases}; (6)$$

$$H_{s}[] = \begin{cases} d^{d-1}r_{k} & \frac{1}{2}c^{2} & h_{k} \end{cases} : (7)$$

Here is proportional to the reduced temperature t, u > 0 stabilizes the H am iltonian H [] for temperatures below the critical point (T < T_c) and (r)² penalizes spatial variations; r_k is a vector parallel to the substrate. The order parameter is uctuating around a mean value h i. Each conguration contributes to the partition function Z with the statistical Boltzm ann weight e H []:

$$Z = D e^{(H_b[]+H_s[])}$$
; (8)

$$h i = \frac{1}{Z}^{Z} D e^{(H_{b}[] + H_{s}[])} :$$
 (9)

In the present work we shall provide general scaling properties with the quantitative results for the scaling functions determined within mean—eld approximation, i.e., only the order parameter pro—lem (z) with the maximum statistical weight will be considered and all others will be neglected:

$$\frac{H[]}{=m} = 0: \tag{10}$$

This mean eld approximation is valid above the upper critical dimension $d_c=4$. this approximation the aforementioned critical exponents take the following values:

(d 4) =
$$\frac{1}{2}$$
 and (d 4) = $\frac{1}{2}$; (11)

whereas the critical exponents at physical dimension d = 3 are [42]:

$$(d = 3) = 0.3265$$
 and $(d = 3) = 0.6305$: (12)

The mean eld approximation is important because it is the zeroth-order approximation in a systematic Feynman graph expansion on which the (= d 4)-expansion and hence the renormalization group approach are based [6, 31, 43]. The higher orders in the Feynman graph expansion require integrations over the mean eld order parameter prole and the two-point correlation function (compare Eq. (3209) in Ref. [31]) which can be carried out reasonably if they are available in an analytical form. However, the mean eld approximation is expected to yield the qualitatively correct behavior of the scaling functions if for the variables forming the scaling variables

the correct critical exponents are used, which are known with high accuracy [42] (see Eq. (12)).

Taking the functional derivative of the H am iltonian with respect to the order parameter (see Eqs. (6), (7), and (10)) yields a dierential equation for the mean eld prolem (z) of the order parameter [30, 31],

$$\frac{e^2}{e^2 z^2} m + m + \frac{u}{3!} m^3 = 0;$$
 (13)

with boundary conditions

$$\frac{\text{@m}}{\text{@z}}_{z=0} = \text{cm} (z=0) \quad h_1$$
 (14)

and

$$\frac{\text{@m}}{\text{@z}}_{z! \ 1} = 0:$$
 (15)

1. In nite surface elds

For systems that belong to the extraordinary surface universality class ($h_1=0;c<0$) the boundary condition at the surface (14) simplies and the dierential equation (13) has an analytical solution [31]. Together with the scaling behavior of the order parameter (1) and the nonuniversal amplitude a which within the present model and within meaneld (MF) approximation equals a = $\frac{6}{u} \, \frac{1}{0} \, 0$ this leads to scaling functions P_{MF} (w) of the following form:

$$P_{MF}^{+}(w) = \frac{P_{Z}^{-}}{\sinh(w + w_{0})}; \quad \coth(w_{0}) = jej; \quad (16)$$

$$P_{MF}(w) = \coth \frac{w + w_0}{2}$$
; $\sinh (w_0) = \frac{1}{E}$; (17)

where c = $_0$ tj $^{\frac{1}{2}}c$ is the scaled and dimensionless surface enhancement. The parameter w_0 vanishes at the extraordinary xed point $K_1=0$;c! 1) { with the scaled and dimensionless surface eld $K_1=\frac{u}{6}$ tj $^{\frac{1}{2}}$ tj $^{\frac{1}{1}}h_1$ { so that Eqs. (16) and (17) reduce to the scaling functions

$$P_1^+ \text{ (w)} = \frac{P_{\overline{2}}}{\sinh (w)}$$
 (18)

and

$$P_1$$
 (w) = $\coth \frac{w}{2}$; (19)

which in the following are referred to as half-space proles" above and below the critical temperature, respectively. As already mentioned at the beginning of Sec. II the extraordinary xed point is equivalent to the normal xed point (j1 j! 1; c=0) and thus Eqs. (18) and (19) represent the latter xed point as well.

2. Finite surface elds

Since in experimental systems the surface elds are nite, we also discuss the case of a homogeneous substrate with a surface eld 0 < h < 1 . This provides the starting point for discussing the case of a chemical step with nite-albeit strong-surface elds which we shall consider in Subsec. IIIA 2. O criticality (i.e., t $\stackrel{\leftarrow}{\bullet}$ 0) and for a nite surface eld h the scaled surface eld h 1= $\frac{u}{6}$ $\frac{1}{2}$ $\frac{1}{2}$) $\frac{1}{2}$ h1 is also nite. At the substrate, for nite surface elds the order parameter pro les $_{\rm h1}^{\rm P}$ (w) above/below the critical temperature have nite values ${\rm P}_{\rm h1}^{\rm +}$ (w = 0) = ${\rm P}_{\rm sub}^{\rm +}$ and ${\rm P}_{\rm h1}$ (w = 0) = ${\rm P}_{\rm sub}^{\rm +}$, respectively. These values are determined by the following equations which are obtained by performing the rst integral of the dierential equations for ${\rm P}_{\rm M}^{\rm +}$ and ${\rm P}_{\rm M}$, corresponding to Eq. (13) [30]:

$$P_{\text{sub}}^{+4} + 2(1 - \hat{e}) P_{\text{sub}}^{+2} + 4e \tilde{h}_1 P_{\text{sub}}^{+} - 2\tilde{h}_1^2 = 0$$
 (20)

and

$$P_{sub}^{4} + 2(1 + 2e^{2}) P_{sub}^{2} 8e \tilde{h}_{1} P_{sub} + 4 \tilde{h}_{1}^{2} = 0: (21)$$

For the normal surface universality class (i.e., e=0) Eqs.(20) and (21) $\sin p \lim_{y \to 0} p \cos y$ and we not for the order param eter P_{sub}^+ and P_{sub} at the substrate above and below the critical tem perature, respectively:

$$P_{\text{sub}}^{+} = \frac{r}{1 + 2\tilde{h}_{1}^{2}} \frac{1}{1 + \tilde{h}_{1}^{2}} 7 0$$
 (22)

and

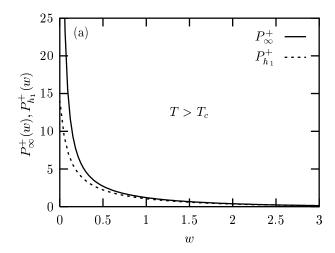
$$P_{\text{sub}} = \frac{r}{1 + 4\tilde{n}_1^2 + 1}; \quad \tilde{n}_1 \ 7 \ 0 :$$
 (23)

U sing these equations together with the boundary condition (14) and the dierential equation (13) the half-space prole for nite surface elds P_1 (w) = P (w; P_1 (see Appendix A). In Fig.2 the half-space proles for in nite and nite surface elds are shown for temperatures above as well as below the critical temperature. In the following section we shall consider inhom ogeneous substrates, i.e., substrates with a laterally varying surface eld P_1 for which further length scales come into play, which also scale with the correlation length .

III. CRITICAL AD SORPTION AT IN HOMOGENEOUS SUBSTRATES

A. Chemical step

First we consider an in nite substrate which is divided into two halves with opposing surface elds h so that there is a chemical step at the straight contact line



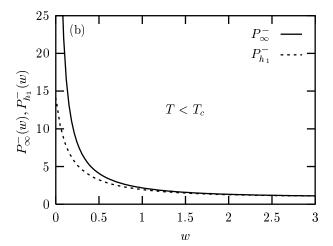


FIG. 2: (a) The half-space pro le P $_1^+$ (w = z= $^+$) for an innite surface eld \tilde{h}_1 and P $_{h_1}^+$ (w = z= $^+$) for a nite scaled surface eld \tilde{h}_1 = 100 above the critical tem perature. (b) The same below T_c with w = z= .

(x=z=0) of the two halves (see Fig.1(a)). We introduce the scaled coordinates v=x= and w=z= describing the distance x from the contact line and z from the substrate, respectively, in units of the correlation length . The system is translationally invariant in the direction perpendicular to the x-z { plane.}

For laterally inhom ogeneous systems one has to reconsider whether the surface H am iltonian H $_{\rm S}$ (Eq.(7)) should contain terms like $\theta_{\rm k}$ and $\theta_{\rm ?}$. However, the term $\theta_{\rm k}$ would favor order parameter proles which are non-symmetric with respect to (x = 0;y) even without surface elds. Therefore such a term is ruled out. The term $\theta_{\rm ?}$ leads only to a rede nition of the surface enhancement [31] and therefore can be neglected for homogeneous as well as for the inhom ogeneous substrates. Thus the surface H am iltonian H $_{\rm S}$ for inhom ogeneous surface elds has the same form as the one for homogeneous

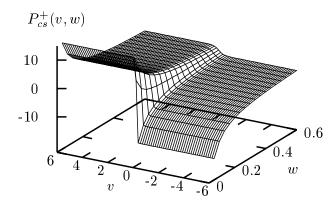


FIG. 3: Scaling function P_{cs}^+ ($v = x = ^+$; $w = z = ^+$) for the order parameter pro le of a system above the critical temperature and conned by a substrate with a chemical step located at x = z = 0. Due to symmetry P_{cs}^+ (v = 0; w = 0) = 0.

surface elds (Eq.(7)).

1. In nite surface elds

First we analyze the case of a hom ogeneous in nite surface eld on both halves of the substrate but with opposite sign and a vanishing surface enhancement, i.e., we consider a step-like lateral variation of the surface eld $h_1:h_1=1$ for x:0. The actual smooth variation of h_1 on a microscopic scale turns electively into a step-like variation if considered on the scale

a. Order param eter pro les

The order parameter prole for a system with a chemical step (cs) exhibits the following scaling property

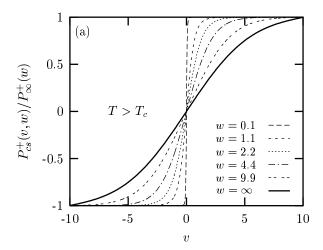
$$(x;z;t) = a \pm j P_{cs} \quad v = \frac{x}{i} = \frac{z}{i}$$
 fort? 0 (24)

which generalizes Eq.(1). This scaling function shows the following limiting behavior: For large distances from the chemical step (jvj! 1) the prole approaches the corresponding order parameter prole of a system with a hom ogeneous substrate, whose asymptotic behavior is given by Eqs.(2)-(4), P_{cs} (jvj! 1;w) = P_1 (w). For large distances from the substrate (w! 1) and above the critical temperature the order parameter prole vanishes for all values of v, i.e., P_{cs}^+ (v;w! 1) = 0 while below the critical temperature the order parameter pro-

le tends to the pro le P_{lv} (v) of a free liquid-vapor interface P_{cs} (v; w! 1) = P_{lv} (v) [44]. the mean eld approximation this pro le is given by

$$P_{lv}(v) = \tanh \frac{v}{2} : \qquad (25)$$

Figure 3 provides a three-dim ensional plot of the nu-



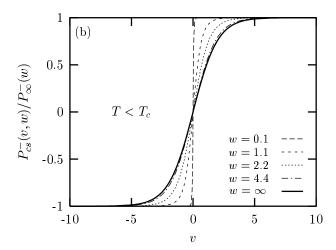


FIG. 4: Cuts through the order parameter pro les $P_{cs}^{+}(v;w)$, as shown in Fig.3, and $P_{cs}(v;w)$ for w=z== const with the normalization $\frac{P_{cs}(v;w)}{P_1(w)}$ (a) above and (b) below the critical temperature. Upon increasing the distance from the substrate the slope of the curves at v=0 decreases. The solid lines represent the limiting curves for w!1: (a) Above the critical temperature the limiting slope at v=0 of the normalized curves is given by $\frac{s^+(w!1)}{P_1^+(w!1)} = \frac{A_p^+}{2^p-2}$ / 0.200 with the slope $s^+(w) = \frac{\theta P_{cs}^+(v;w)}{\theta v}$ of the unnormalized scaling function and its amplitude A_2^+ / 0.566 (see, c.f., Eq. (28) and Fig.5). (b) Below T_c the limiting curve corresponds to $tanh(\frac{v}{2})$.

m erically determ ined (see Appendix A) order parameter pro le for $T > T_c$. In Fig.4 we show cuts through the order parameter pro le parallel to the substrate as it changes with increasing distance from the substrate. In order to provide a clearer comparison the cross sections are normalized to 1 at the lateral boundaries via dividing by the exponentially decaying half-space pro le P_1 (w). From the fact that the cross sections do not fall onto one curve follows that the scaling function P_{cs} (v; w)

does not separate into a v-dependent and a w-dependent part. It shows that the slope s $(w) = \frac{\theta P_{cs} (v; w)}{\theta v}$ of the scaling function at the step decreases with increasing distance from the substrate which visualizes the healing of the frustration upon approaching the bulk. Note that the slopes in Fig.4 m ust be multiplied by P_1 (w) in order to obtain s (w). From Eq.(24) it follows:

$$\frac{\theta \quad (x;z;t)}{\theta x} = a \frac{fj}{\theta v} \frac{\theta P_{cs}(v;w)}{\theta v} = \frac{a}{\theta v} \frac{fj}{\theta v} = 0$$

$$= \frac{a}{\theta v} fj^{+} s(w) : (26)$$

Since there is a non-vanishing order parameter proleeven at the critical point ($(x;z;t=0) \in 0$) the overall temperature dependence of the slope $\frac{\theta}{\theta \cdot x}$ in Eq.(26) has to vanish. Therefore one independence of the slope $\frac{z}{\theta}$ to $\frac{z}{\theta}$.

$$s (w ! 0) = A_1 w^{-1} :$$
 (27)

For $T > T_c$ the slope s^+ (w) vanishes exponentially upon approaching the bulk:

$$s^+$$
 (w ! 1) = A_2^+ e w : (28)

Below T_c the slope s (w ! 1) approaches the slope $s_{lv} = \frac{\theta P_{lv}(v)}{\theta v}$ of the scaling function for the liquid-vapor proble (Eq. (25)) at most e^w or slower:

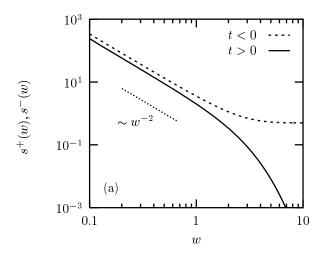
s (w ! 1)
$$g_v = A_2 e^{Cw}$$
; 0 < C 1: (29)

As the half-space pro les P_{cs}^+ (v ! 1; w) = P_{c}^+ (w) (Eq.(4)) decay exponentially e w for large distances from the substrate, the slope s (w) cannot decay faster because this would require that the slope s (w) is smaller than the slope $\frac{\theta P_{cs}^+}{\theta v}$ for a certain $v_0 \in 0$. On the other hand a decay of the slope s '(w) slower than e w ould lead to an unphysical increasing slope of the normalized cross sections at v = 0 with increasing distance from the substrate. However, for the slope s (w) a decay towards s_{lv} slower than e w cannot be ruled out.

W ithin mean eld theory Eqs.(27) and (25) yield s (w ! 0) w 2 (see also Eq.(11)) and s (w ! 1) = $\rm s_{lv} = \frac{1}{2}$, respectively, which is in agreement with the numerical results shown in Fig.5. These results for the slope s (w) of the scaled order parameter pro le $\rm P_{cs}$ (v;w) transform into the following ndings for the slope of the unscaled order parameter pro le (x;z):

$$\frac{\theta}{\theta x} \Big|_{x=0} = z^{-1}; \quad T = T_{c}; \qquad (30)$$

$$\frac{\theta}{\theta x} \Big|_{x=0} = t^{+} e^{\frac{z}{+}}; \quad T > T_{c}; \quad z^{-} ; \qquad (31)$$



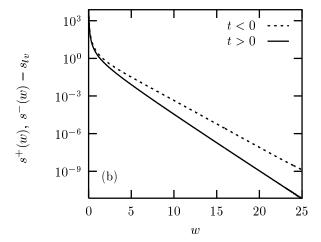


FIG. 5: Slopes s (w) at the chem ical step of the scaling functions P_{cs} (v = x= ;w = z=) for the order parameter pro le of a system with a chem ical step at x = 0. (a) For small distances from the substrate the slopes diverge as A_1 w 2 with amplitudes $A_1^+=2.367-0.006$ and $A_1=3.366-0.005$ (see Eq. (27)). (b) For large distances the slopes decay exponentially, above T_c s $^+$ (w ! 1) = A_2^+ e $^{\rm W}$ with $A_2^+=0.566-0.001$ (see Eq. (28)); below T_c s (w ! 1) approaches its limiting value $s_{\rm lv}=\frac{1}{2}$ slower, i.e., as A_2 e $^{\rm CW}$ with $A_2^-=2.338-0.001$ and C=0.858-0.001 (see Eq. (29)).

$$\frac{0}{0x} \Big|_{x=0} = \frac{0}{0x} \Big|_{x=0} = \frac{0}$$

As an example we investigate more closely the healing e ect above the critical temperature. To this end we rescale the normalized cross sections of Fig.4 such that their slope at v=0 becomes 1, see Fig.6. It shows that these rescaled normalized cross sections for dierent distances from the substrate dier basically only in the

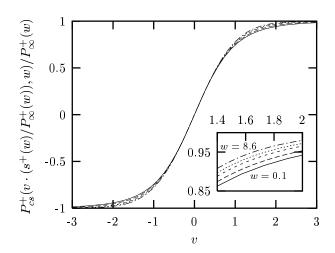


FIG. 6: Rescaled normalized cross sections with slope 1 at v = 0 for w = 0.1; 1.5; 2.9; 4.3; 8:6.

region where the curvature of these curves is largest. From the fact that these cross sections do not fall onto one curve it follows that the scaling function P (v;w) is not simply given by the know ledge of one cross section, the slope s(w), and the half space pro $le\ P_1^+$ (w) but requires the full numerical analysis. Nonetheless Fig.6 demonstrates that to a large extent the rescaling used there reduces the full scaling function $P_{cs}^+(v;w)$ to a single function of v only.

b. Excess adsorption

It is a challenge to determ ine experim entally the fullor-der parameter pro le (x;z). Therefore in the following we analyze the adsorption = dV (r) at the substrate which as an integral quantity is more easily accessible to experiments. To this end for any system with an order parameter pro le (x;z) and a corresponding scaling function P (v;w) we introduce a suitable reference system with an order parameter pro le (x;z) and the corresponding scaling function (v;w). This allows us to introduce an excess adsorption (v;w) with respect to this reference system

$$\begin{array}{l} x \\ ex = H & dx dz ((x;z)) \\ = a t \\ \end{array}$$

$$\begin{array}{l} x \\ dx dz ((x;z)) \\ \end{array}$$

$$\begin{array}{l} x \\ ref (x;z) \\ \end{array}$$

with its universal part $^{\sim}_{\rm ex}$ de ned as (see Eqs.(1) and (24))

$$^{\sim}_{\text{ex}} = \text{dvdw P (v;w)} \quad P_{\text{ref}} \text{ (v;w)} : (34)$$

H denotes the extension of the system perpendicular to the x-z { plane. (In the three-dimensional case H corresponds to the one-dimensional extension of the system in y-direction. W ithin mean eld theory, which is valid for dimensions d 4, H corresponds to the d 2-dimensional

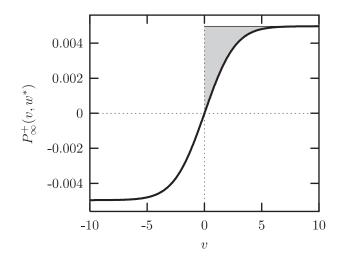


FIG. 7: The shaded area indicates the contribution to the excess adsorption $^{\sim}_{\rm ex,cs}$ as de ned in Eq.(37) for w=w=6.0 for a system above $T_{\rm c}$ and with a chemical step. $^{\sim}_{\rm ex,cs}$ is obtained by sum ming these shaded areas over w.

extension of the system in the y_1 :: y_d $_2$ -directions.) Equation (33) leads to the following temperature dependence of the excess adsorption:

$$_{\text{ex}} = _{\text{ex}}^{\text{a}} \text{a}_{0}^{2} \text{H} \text{ jj}^{2} ;$$
 (35)

with the universalam plitude $^{\circ}_{\rm ex}$ and three non-universal amplitudes a, $_0$, and H . Within mean eld approximation this yields $_{\rm ex}$ = $^{\circ}_{\rm ex}$ a $_0^{-2}$ H jtj $^{\frac{1}{2}}$. For our choices of reference systems as given below P $_{\rm ref}$ (v;w) leads even within mean eld theory to a cancellation of the divergence of the corresponding integrals over the scaling function P (v;w) caused by small distances from the substrate. This way the numerical mean eld data for d = 4 allow one to make meaningful approximate contact with potential experimental data for d = 3.

Speci cally, for the chem ical step we introduce a reference system $P_{\text{cs};0}$ (v;w) which can be interpreted as a system with a chem ical step for which no healing at the chem ical step occurs:

$$P_{cs;0}(v;w) = \begin{pmatrix} P_1 & (w) & ; & v < 0 \\ P_1 & (w) & ; & v > 0 \\ P_1 & (w) & ; & v > 0 \end{cases}$$
(36)

Since this choice of the reference system s leads to a vanishing excess adsorption for any antisymmetric (with respect to v=0) scaling function $P_{cs}\left(v;w\right)$ upon integration over the whole half space w>0, we restrict the integration to a quarter of the space (see Fig.7):

$$\sim_{\text{ex;cs}} = \int_{0}^{\text{Z}_{1}} dv \quad \text{dw} \quad P_{\text{cs}}(v;w) \quad P_{\text{cs;0}}(v;w) : (37)$$

For a binary liquid m ixture con ned by a substrate with a chemical step $_{\rm ex;cs}$ can be interpreted as the amount

of particles of one type rem oved across the chem ical step from the substrate which prefers them .

Below T_c the scaling function P_{lv} (v) = P_{cs} (v; w = 1) (Eq.(25)) of the liquid-vapor prole gives rise to a non-vanishing universal excess adsorption \tilde{b} with respect to the chosen reference system $P_{cs:0}$:

$$\begin{array}{rcl}
 & Z_{1} \\
 & Z_{0} \\
 & Z_{1}^{0}
\end{array}$$

$$\begin{array}{rcl}
 & Z_{1}^{0} \\
 & Z_{1}^{0}
\end{array}$$

Thus ~ex;cs can be written as

$$^{\sim}_{\text{ex;cs}} = \text{1 }^{\sim}_{\text{b}} + \text{0}^{\sim}_{\text{ex;f}}$$
 (39)

where $\Gamma = L = 0$! 1 denotes the extension of the system perpendicular to the substrate and the system size independent contribution $_{\rm ex;f}$ characterizes the in uence of the chemical step. From our numerical analysis we not the following universal excess adsorption amplitudes:

$$c_{\text{ex:cs}}^{+} = 1:457 \quad 0:001; \tag{40}$$

$$_{\text{ex:f}}^{\sim} = 1.299 \quad 0.001:$$
 (41)

2. Non-antisymmetric nite surface elds

Next we study an in nite substrate consisting of two halves with surface elds of opposite sign but dierent absolute nite values h_p and h_n , respectively, and a vanishing surface enhancement. As before we consider a step-like variation of the surface eld h:

$$h_1(x) = \begin{pmatrix} h_n & ; x < 0 \\ h_p & ; x > 0 : \end{pmatrix}$$
 (42)

The absence of antisymmetry for these systems is reected by the \zero-line" $v_0(w)$, where the order parameter vanishes: $P(v_0; w) = 0$. For ratios $\tilde{h}_p = \tilde{h}_n \in 1$ of the scaled surface elds (see Subsec. II 2) the zero-line is shifted towards the region of the surface eld with the smaller absolute value. Furthermore the zero-line is not straight, but tends to increasing values jv_0 jfor increasing distance w from the substrate. However, the deviation of the zero-line from the line (v = 0; w) decreases for $\tilde{h}_p = \tilde{h}_n$! 1. For constant ratios $\tilde{h}_p = \tilde{h}_n$ the deviation of the zero-line from the line (v = 0; w) decreases w ith

of the zero-line from the line (v=0;w) decreases w ith increasing absolute values of the scaled surface $elds \tilde{n}_p$ and \tilde{n}_n . These results demonstrate how the order parameter structure for the $elds \tilde{n}_p$; f_n ; f_n ; f_n is emerges smoothly from the general case of nite elds. In this sense in the following we focus on the case of in nite surface elds, i.e., strong adsorption.

B. Single stripe

The second system we focus on consists of a laterally extended substrate with a negative surface eld h !

1 in which a stripe of width S with a positive surface eld h ! 1 is embedded (see Fig.1(b)). The surface eld h is assumed to vary step-like:

$$h_1(x) = \begin{pmatrix} +1 & ; & x & 2 & [0; S] \\ & 1 & ; & x \not\geq & [0; S] \end{cases}$$
 (43)

We introduce the coordinates v and w scaled in units of the correlation length, where v denotes the scaled distance from the left border of the stripe at x=0 and w the scaled distance from the substrate. The in uence of the stripe width S and of the reduced temperature t are captured by the scaled stripe width S=S=. The order parameter prole for the system with a single stripe (ss) exhibits the scaling property

$$(x;z;t;S)$$

$$= atj P_{ss} v = \frac{x}{}; w = \frac{z}{}; S = \frac{S}{}$$
 (44)

with the limiting behavior

$$P_{ss}(v; w; S = 0) = P_1(w);$$
 (45)

$$P_{ss}(v;w;S'!1) = P_{cs}(v;w):$$
 (46)

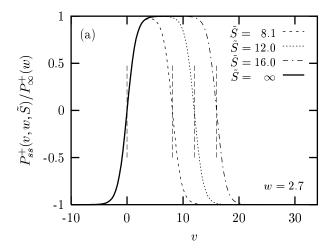
Figures 8 (a) and 8 (b) show cross sections (parallel to the substrate) through the order param eter scaling function P_{ss}^+ (v;w;S) for system swith dierent scaled stripe width S at two dierent scaled distances w from the substrate in comparison with a cross section through the order parameter pro le P_{cs}^+ (v;w) at a single chemical step at v=0 (see Subsec.IIIA). With increasing scaled width S! 1 of the stripe the left part of the cross section of the stripe system merges with the cross section of the system with a single step. Further away from the substrate the mutual in uence of the two step structures onto each other is more pronounced (see Fig. 8 (b)) and stronger for smaller stripes.

For systems with a single chemical stripe on the substrate a reference system with the scaling function $P_{ss;0}^+$ (v;w;S) can be introduced similar to the one for a single chemical step which can be interpreted as a system with a single chemical stripe on the substrate where no healing occurs:

$$P_{ss;0}^{+}(v;w;S) = \begin{pmatrix} & & & & \\ & +P_{1}^{+}(w); & \text{jvj2} & [0;S] \\ & & & & \\ & & P_{1}^{+}(w); & \text{jvj2} & [0;S] \end{cases}$$
(47)

This reference system allows us to de ne the excess adsorption $^{\sim +}_{\rm ex;ss}$ for the striped system s:

$$\sum_{\text{ex;ss}}^{+} (S') = \sum_{\text{1}}^{2} \sum_{\text{1}}^{1} \text{dv} \text{dw} \quad P_{\text{ss}}^{+} (v; w; S') \\
= \sum_{\text{1}}^{+} \sum_{\text{0}}^{1} (v; w; S') \quad (48)$$



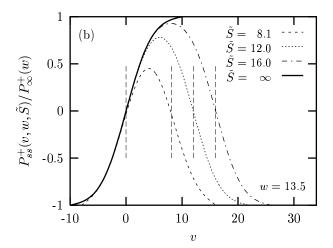


FIG. 8: Comparison between the normalized cross sections of the order parameter scaling function near a substrate with negative surface eld in which a stripe with positive surface eld of scaled width S is embedded and the normalized cross sections of the order parameter prolenear a single chemical step (which emerges as limiting case for S ! 1), (a) at a scaled normal distance w = 2:7, (b) at w = 13:5. Here we consider the case T > T_c . The chemical steps are located at x = 0 and x = S corresponding to v = 0 and v = S (see vertical lines).

Equation (48) can be rewritten as

where B = B S is the overall lateral extension of the substrate surface in x-direction (see Fig.1(b)) and $^{+}_{1}$ = $^{R_{1}}_{0}$ dw P $_{1}^{+}$ (w) is a universal number characterizing the amplitude of the excess adsorption at a hom ogenous substrate: $^{0}_{0}$ dz (z;t) = $^{+}_{1}$ a $^{+}_{0}$ t . The value

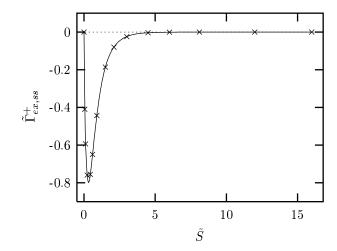


FIG. 9: Universal excess adsorption $^{+}_{\text{ex},\text{iss}}$ (Eq.(48)) for a single stripe with respect to a system with no healing as a function of the stripe width S. For S=0 the system corresponds to a system with a homogeneous substrate whose corresponding excess adsorption is 0. In the lim it S! 1 the stripe system corresponds to two independent chemical steps whose excess adsorption also vanishes due to antisym metry of the proles around v=0 and v=S! 1. The non-vanishing excess adsorption for intermediate stripe widths S indicates the elect of the stripe with a surface eld opposite to the one of the embedding substrate. $^{+}_{\text{ex},\text{iss}}$ attains its minimum at S' 03.

of $^{*}_{1}$ is discussed in Ref. [33] and in Ref. [25] where it is denoted as $^{*}_{1}$ = g_{+} = () (see Eq. (2.9) and Fig.5 in Ref. [25]; in d = 3 one has $^{*}_{1}$ = 2.27). Equation (49) describes how in an operational sense the universal function $^{*}_{\text{ex},\text{rs}}$ (5°) (see Fig.9) can be obtained from the measurements of the excess adsorption (relative to the bulk order parameter) at a striped surface and from those of the excess adsorption at the corresponding homogeneous surface.

Figure 9 shows the dependence of the excess adsorption $^{*}_{\rm ex;ss}$ on the scaled stripe width S. For S! 1 the structures associated with the two chem ical steps forming the stripe decouple so that $^{*}_{\rm ex;ss}$ (S! 1) = 0. Upon construction $^{*}_{\rm ex;ss}$ (S = 0) = 0. The decrease of the excess adsorption at S = 1 arises due to the fact that for su ciently small stripes the spatial region where the order parameter prole is positive does no longer resemble a rectangular but a tongue-like shape (see Fig.10). Since for the reference system the region with a positive order-parameter resembles still a rectangle this leads to a negative excess adsorption.

For dierent stripe width S the tongue-like regions dened by the zero-lines $v_0(w)$ where the order parameter vanishes, $P(v_0; w) = 0$, are shown in Fig.10. The width of the tongue at the substrate is given by the stripe width S due to the in nitely strong surface elds. With increas-

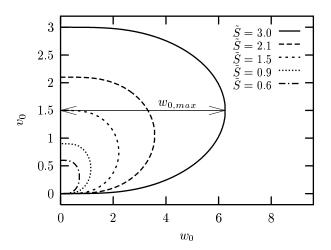


FIG. 10: Zero-lines v_0 (w) where the order parameter vanishes: P (v_0 ; w) = 0 for dierent stripe widths S. Outside the tongue the order parameter is negative corresponding to the preference of the substrate outside the stripe. Inside the tongue the order parameter is positive and thus demarcates the range of the in uence of the stripe with opposite preference.

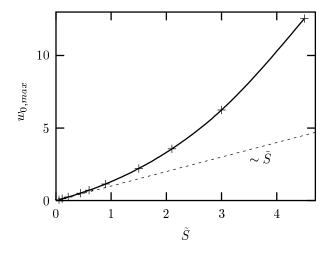


FIG. 11: Dependence of the length $w_{0\,\mathrm{m}~\mathrm{ax}}$ of the tongues shown in Fig.10 on the stripe width S. For sm all stripe widths the length of the tongue increases linearly, with increasing stripe widths S the length $w_{0\,\mathrm{m}~\mathrm{ax}}$ of the tongues diverges.

ing stripe width S the tongue becomes longer. Fig.11 shows the dependence of the length $w_{0\,\mathrm{pm}~ax}$ of the tongue on the stripe width S. It shows that for small stripes $w_{0\,\mathrm{pm}~ax}$ increases linearly with S.

C. Periodic stripes

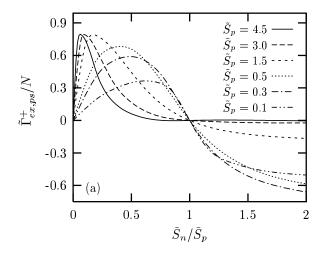
As a natural extension we now consider a substrate with a periodic array of stripes with alternating sur-

face elds (see Fig.1 (c)): stripes of width S_p (S_n) with positive (negative) surface eld h_l ! 1 (h_l ! 1). In the lateral x-direction we employ periodic boundary conditions. The corresponding scaling function P_{ps} for the order parameter distribution near the substrate with periodic stripes (ps) depends on two scaled coordinates $v=x=^+$ and $w=z=^+$ and on two scaled stripe widths $S_p=S_p=^+$ and $S_n=S_n=^+$ or, equivalently, S_p and $S_n=S_p=S_p$. Thus in the series P_1 , P_{cs} , P_{ss} , and P_{ps} each scaling function acquires one additional scaling variable. Considering the excess adsorption $C_{ex,ps}^+$ (S_p ; $S_n=S_p$) reduces the number of scaling variables to two:

where $P_{ps;0}^+ = P_1^+$ (w) on the positive stripe and $P_{ps;0}^+ = P_1^+$ (w) on the negative stripe. N is the number of periodic cells on the substrate. In analogy to Eq. (49) one has

As compared with the case of a single stripe the periodic arrangement enhances the excess adsorption by the (potentially large) number of lateral repeat units. Figure 12 (a) shows that $^{+}_{\rm ex,ps}$? 0 for S_p ? S_n . $^{+}_{\rm ex,ps}$ vanishes at $S_n=0$ because this corresponds to the limiting case of a homogeneous substrate. $^{+}_{\rm ex,ps}$ also vanishes for $S_n=S_p$ due to symmetry reasons. The limit $S_n=S_p$! 1 with S_p and leads to the case of a single stripe of width S_p ; this corresponds to Fig.9 up to the factor N . In Fig.12 (b) the loci of the maxima of the excess adsorption $^{+}_{\rm ex,ps}=N$ for dierent stripe widths S_p and S_n are given.

The positive values of the excess adsorption $\overset{\leftarrow}{\text{ex},ps}$ are again caused by the tongue-like regions within which the order parameter prole has a denite sign. For $S_p < S_n$ there is a nite tongue-like region adjacent to each positive stripe within which the order parameter is positive and negative outside of it. For S_p ! S_n the tongue length diverges and the tongue boundaries degenerate into two parallel lines orthogonal to the substrate. For $S_p > S_n$ there are tongues of negative values of the order parameter adjacent to the negative stripes. Figure 13 shows the length $w_{0,m}$ ax of the tongues on the stripe width S_n for dierent ratios $S_n = S_p$. With increasing ratio $S_n = S_p$!



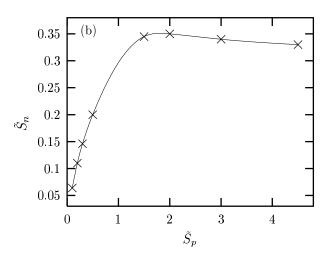


FIG. 12: (a) Universal scaling function for the excess adsorption $^{+}_{\text{ex},ps}$ per unit cell (Eqs. (50) and (51)) for a system with a periodic stripe pattern of negative and positive surface elds with scaled widths $\mathcal{S}_n = S_n =$ and $\mathcal{S}_p = S_p =$, respectively. The case $\mathcal{S}_n = \mathcal{S}_p = 0$ corresponds to a hom ogeneous substrate with a positive surface eld. The excess adsorption vanishes for $S_n = S_p$ due to sym m etry reasons. For large ratios $\mathcal{S}_n = \mathcal{S}_p$ with \mathcal{S}_p xed the excess adsorption $^{+}_{\text{ex},ps} = \mathbb{N}$ tends to the excess adsorption of a single stripe of width \mathcal{S}_p which is given by Fig.9. (b) Loci of the maxim a of $^{+}_{\text{ex},ps} = \mathcal{S}_p = \mathbb{S}_p = \mathbb{N}$.

the lim it of a substrate with a single positive stripe of width ${\mathcal S}_{\rm p}$ in a negative matrix is reached.

IV. SUMMARY

Based on mean eld theory combined with renomalization group arguments we have studied critical adsorption of uids at chemically structured substrates. The uids are either one-or two-component liquids near their gas-liquid critical point or binary liquid mixtures near

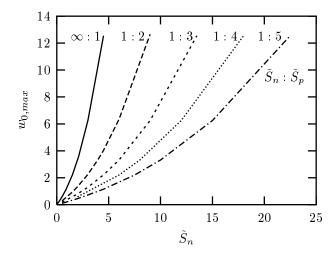


FIG. 13: Dependence of the rescaled length $w_{0\,m}$ ax of the tongues within which the order parameter adjacent to a stripe maintains the sign preference of the stripe (compare Fig.10) on the stripe width S_n for dierent ratios $S_n = S_p$. The limit $S_n = S_p$! 1 corresponds to the case of a single stripe of width S_p . The full curve corresponds to the latter case (see also Fig.11) and is denoted as 1:1.

their critical dem ixing point. In the set case the order param eter is given by the local total density, in the second case by the local concentration. We have determined the order param eter proles and suitably dened excess adsorptions for three substrate types: a single chemical step, a single chemical stripe, and a periodic stripe pattern (see Fig.1). We have obtained the following main results:

- 1. The order parameter proles and the excess adsorption can be described in terms of universal scaling functions (Eqs. (24), (35), (39) (41), (44), (49), (51)). The excess adsorptions are introduced relative to order parameter proles at homogeneous substrates (Sec. II and Fig. 2) taken to vary step-like in lateral direction according to the actual chemical pattern under consideration.
- 2. The speci c shapes of the scaling functions are determ ined within mean eld theory. For the chemical step the full scaling function of the order parameter proles is shown in Fig.3 in terms of the scaling variables v = x = and w = z = given by the lateral (x) and the normal (z) coordinates in units of the bulk correlation length. Lateral cuts through the normalized scaling function w ith an emphasis on its asymptotic behavior far from the substrate are shown in Fig.4. For the case of strong adsorption considered here the slopes of the scaling function across the chemical step increase w^2 upon approaching the surface and decay e^{Cw} towards the bulk w ith C = 1 above T_c and C < 1

below T_c (Fig.5). To a large extent the variation of the full scaling function norm alto the surface can be absorbed by rescaling the lateral variation suitably (Fig.6). The excess adsorption at the chem ical step (Eq. (37) and Fig.7) lead to universal numbers above (Eq. (40)) and below T_c (Eqs. (39) and (41)).

- 3. The lateral variation of the order parameter adjacent to a single chemical stripe is shown in Fig.8 in terms of its suitably normalized scaling function. Figure 8 visualizes the dependence of these structures on the scaled stripe width. Figure 10 illustrates the in uence of a chemical stripe of width S on the adjacent order parameter. The range of this in uence, de ned as the spatial region of maintaining the preferred sign of the order parameter, generates tongue-like structures which grow with increasing stripe width (Fig.11). The excess adsorption (Eq.(49)) is described by a universal scaling function in terms of S = S = which is maximal for S' 0:3 (Fig.9).
- 4. For a periodic stripe pattern of N unit cells the scaling function for the order parameter depends on four scaling variables: v, w, $S_p = S_p =$, and $S_n = S_n = where S_p$ and S_n are the width of the stripes with positive and negative surface elds, respectively. The range of in uence (see 3. above) of the narrower stripes is again con ned to tonguelike structures which grow with increasing stripe width (Fig.13). The corresponding excess adsorption (Fig.12(a)) is given by a universal scaling function in terms of S_p and S_n which describes the interpolation between the homogeneous substrate $(S_n = S_p = 0)$ and a single stripe of width S_p ($S_n = S_p = 1$, S_p xed). The relation between S_p and S_n which yields the maximum excess adsorption is shown in Fig. 12 (b).

APPENDIX A: NUMERICAL METHODS

In the following, we provide some details of the numerical methods which we have applied. The order parameter proles are be calculated numerically from Eqs. (13) – (15) by introducing a discrete lattice with nite spatial extensions. The extension of the system perpendicular to the substrate (z-direction) is L, the extension in the direction of the inhomogeneity of the substrate (x-direction) is B. The corresponding lattice spacings are denoted as dz and dx. Since the system is translationally invariant in the d 2 directions perpendicular to the x z-plane (where d denotes the spatial dimension

of the system), the numerical problem is electively two-dimensional.

For the calculation of the scaling functions these quantities are scaled with the correlation length—leading to the scaled length Γ in w-direction, the scaled width Γ in v-direction, and the corresponding lattice spacings dw and dv, respectively. In order to m in ic the characteristics of an in nitely extended system we choose an exponentially decaying continuation of the order parameter proles as the boundary condition at the distance Γ from the substrate. (For the non-antisym metric pro-

les we resort to a constant continuation.) In the case of the substrate with a single chemical step (cs) or a single stripe (ss) we choose the width B' such that the system is su ciently broad so that the in uence of the chem ical steps at the lateral boundaries is negligible and the order param eter attains the value of the corresponding half-space pro le P_1 (w) for in nite surface elds h_1 ! 1 or P_{h_1} (w) for nite surface elds h < 1 : $P_{cs}(\frac{B^{r}}{2};w) = P_{1;h_{1}}(w), P_{ss}(\frac{B^{r}}{2};w) = P_{1;h_{1}}(w).$ For the substrate with periodic stripes one can focus on a single unit cell so that the scaled width B is the sum of the stripe widths \mathcal{S}_p and \mathcal{S}_n with periodic boundary conditions: $P_{ps} (+ \frac{B^r}{2}; w) = P_{ps} (\frac{B^r}{2}; w)$. The choices for the width B' and the length I of the system are not com pletely independent, i.e., for a given length I there is a m in im um width B so that L and B span a region in which the order parameter pro le is calculated correctly under the chosen boundary conditions. It turns out that a width B & 16 is su cient for the studied range of lengths L. 20. For the substrates with a single stripe the width S of the negative matrix is chosen as B S & 16 and is kept constant for di erent widths of the stripe. We use the steepest descent method in order to calculate the order param eter pro les. The values of the scaling function P (v; w) of the order param eter at each lattice point are split into an initial part P in (v; w) (see the pro les for systems where no healing occurs given by Eqs. (36) and (47)), which is the known solution for a system similar to the one under consideration, and a correction term P_{corr} (v; w) which is varied in accordance with the steepest descent method. This procedure is described in detail in Ref. [45]. The excess adsorption depends on the value of the lattice spacings dv and dw, respectively, used for its num erical calculation. Therefore we have calculated the excess adsorption for di erent lattice constants and extrapolated it to dv = dw = 0. It also depends on the length of the system. Hence we calculated the order param eterpro les for a xed width and di erent lengths Γ . For lengths larger than $\Gamma = 10$ the results are indistinguishable, i.e., for these lengths corrections with respect to an in nitely long system are negligible.

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